CLAIMS

1. A method, comprising:

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- a) providing meltable material and a device, said device comprising:

 an inlet port in fluidic communication with a first microchannel, said first
 microchannel having a middle section and an end section, said end section
 intersecting a second microchannel at a junction, wherein a first heater
 element is associated with said inlet port, a second heater element is
 associated with said middle section of first microchannel, and a third
 heater element is associated with said second microchannel at said
 junction, and wherein said inlet port is linked to a gas source;
- b) introducing said meltable material at said inlet port;
- c) activating said first heater element under conditions such that said meltable material at least partially melts to created melted material;
- d) applying pressure with said gas source to said melted material; and
- e) activating said second heater under conditions such that said melted material remains melted, moves to said junction and at least partially solidifies, thereby creating a plug at said junction blocking said second microchannel.
- 2. The method of Claim 1, wherein steps (b) and (c) are performed in any order.
- The method of Claim 1, wherein steps (b) and (c) are performed simultaneously.
 - 4. The method of Claim 1, wherein steps (d) and (e) are performed in any order.
 - 5. The method of Claim 1, wherein steps (d) and (e) are performed simultaneously.
 - 6. The method of Claim 1, wherein steps (c), (d) and (e) are performed simultaneously.

- 7. The method of Claim 1, wherein said gas source is an air source.
- 8. The method of Claim 1, wherein said junction is configured as a "T" junction.
- 9. The method of Claim 1, wherein said junction is configured as a "Y" junction.
- 10. The method of Claim 1, wherein said said meltable material is selected from a group consisting of solder, plastic, polymer, electrorheological fluid and wax.
 - 11. The method of Claim 1, wherein after said melted material moves to said junction in step (e), said melted material is allowed to cool.
 - 12. The method of Claim 1, wherein said inlet port is further linked to a vacuum.
- 10 13. The method of Claim 12, further comprising:

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- (f) activating said third heater under conditions such that plug at said junction at least partially melts so as to create an at least partially melted plug; and
- (g) applying a vacuum through said inlet port under conditions such that said at least partially melted plug is retracted from said junction, thereby unblocking said second microchannel.
- 14. The method of Claim 13, further comprising activating said second heater at approximately the same step (f) is performed.
- 15. A method, comprising:
 - a) providing meltable material and a device, said device comprising:
 an inlet port in fluidic communication with a first microchannel, said first
 microchannel disposed in a substrate and having a middle section and an
 end section, said end section intersecting a second microchannel at a
 junction, said second microchannel disposed in a substrate, wherein a first
 heater element is associated with said inlet port, a second heater element is

- associated with said middle section of first microchannel, and a third heater element is associated with said second microchannel at said junction, and wherein said inlet port is linked to a gas source;
- b) introducing said meltable material at said inlet port;

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- c) activating said first heater element under conditions such that said meltable material at least partially melts to created melted material;
- d) applying pressure with said gas source to said melted material; and
- e) activating said second heater under conditions such that said melted material remains melted, moves to said junction and at least partially solidifies, thereby creating a plug at said junction blocking said second microchannel.
- 16. The method of Claim 15, wherein steps (b) and (c) are performed in any order.
- 17. The method of Claim 15, wherein steps (b) and (c) are performed simultaneously.
- 18. The method of Claim 15, wherein steps (d) and (e) are performed in any order.
- 15 19. The method of Claim 15, wherein steps (d) and (e) are performed simultaneously.
 - 20. The method of Claim 15, wherein steps (c), (d) and (e) are performed simultaneously.
 - 21. The method of Claim 15, wherein said gas source is an air source.
 - The method of Claim 15, wherein said junction is configured as a "T" junction.
- 20 23. The method of Claim 15, wherein said junction is configured as a "Y" junction.
 - 24. The method of Claim 15, wherein said said meltable material is selected from a group consisting of solder, plastic, polymer, electrorheological fluid and wax.

- 25. The method of Claim 15, wherein after said melted material moves to said junction in step (e), said melted material is allowed to cool.
- 26. The method of Claim 15, wherein said inlet port is further linked to a vacuum.
- 5 27. The method of Claim 26, further comprising:

- (f) activating said third heater under conditions such that plug at said junction at least partially melts so as to create an at least partially melted plug; and
- (g) applying a vacuum through said inlet port under conditions such that said at least partially melted plug is retracted from said junction, thereby unblocking said second microchannel.
- 28. The method of Claim 27, further comprising activating said second heater at approximately the same step (f) is performed.
- 29. The method of Claim 15, wherein said substrate is selected from the group consisting of glass and silicon.
- 30. A device, comprising: an inlet port in fluidic communication with a first microchannel, said first microchannel having a middle section and an end section, said end section intersecting a second microchannel at a junction, wherein a first heater element is associated with said inlet port, a second heater element is associated with said middle section of first microchannel, and a third heater element is associated with said second microchannel at said junction, and wherein said inlet port is linked to an air source and a vacuum source